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PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Our Case No. 03-05)

In re Application of:

Christopher Lyons et al.

Serial No.: 10/790,567

Filed: March 1, 2004

For: Patterning with Rigid Organic Under-layer

Group Art Unit: 2822

Examiner: Christy L. Novacek

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

TRANSMITTAL LETTER

In regard to the above identified application:

1. We are transmitting herewith the attached Response to Restriction Requirement; and postcard

2. With respect to additional fees:

X A. No additional fee is required.

B. Attached is a check in the amount of \$.

3. CERTIFICATE OF MAILING UNDER 37 CFR § 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described in paragraph 1 hereinabove, are being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 4th day of October, 2005.

By

Monica H. Choi

Reg. No. 41,671



CERTIFICATE OF MAILING

The undersigned hereby certifies that the foregoing RESPONSE TO RESTRICTION REQUIREMENT is being deposited in the United States Postal Service, as first class mail, postage prepaid, in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 4th day of October, 2005.

Monica H. Choi
Reg. No. 41,671



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Commissioner for Patents
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Alexandria, VA 22313-1450

Dear Sir:

RESPONSE TO RESTRICTION REQUIREMENT

Applicants submit the following in response to the Office Action mailed on September 23, 2005, which sets a 1-month period for response.

The Examiner requires election between the following inventions:

Invention I: Claims 1-13, drawn to a method of making a semiconductor device, classified in class 438, subclass 694.

Invention II: Claims 14-25, drawn to an apparatus for making a semiconductor device, classified in class 156, subclass 345.1.

Applicants hereby elect Invention I with claims 1-13.

CONCLUSIONS

Applicants have effectively and timely responded to the Restriction Requirement dated September 23, 2005. Please feel free to contact the undersigned should any questions arise with respect to this case that may be addressed by telephone.

Respectfully submitted,
for Applicant(s)

Dated: October 4, 2005

By:



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